

Correlation between the Low-Temperature Photoluminescence Spectra and Photovoltaic Properties of Thin Polycrystalline CdTe Films

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Abstract

A dominant intrinsic luminescence band, which is due to the surface potential barriers of crystalline grains, and an edge doublet, which arises as an LO-phonon repetition of the e-h band, has been revealed in the low-temperature photoluminescence spectra of fine-grained obliquely deposited films. Doping film with In impurity leads to quenching of the doublet band, while further thermal treatment causes activation of the intrinsic band, the half-width and the blue shift of the red edge of which correlates with the maximum value of anomalously high photovoltage generated by the film.

Keywords

Film Structures, Low-Temperature Photoluminescence, Crystalline Grains, Surface Potential Barriers, Anomalous Photovoltaic Properties, Thermal Treatment, Photocarriers, Intrinsic Luminescence Band, LO-Phonon Repetitions

1. Introduction

Low-temperature photoluminescence (LTPL) spectroscopy is one of the most sensitive and informative optical methods for studying semiconductors and film structures. LTPL spectra of CdTe crystals has been investigated in detail, and new methods for predicting and controlling electrical properties of semiconductor structures have been proposed on their basis. In particular, based on the study of the dynamics of changes in photoluminescence

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spectra [1] [2], a method for deep sample purification was developed, and polycrystalline CdTe of stoichiometric composition with a photoluminescence spectrum containing only the exciton component and no impurity contributions was obtained. The electron spectra of CdTe:In [3] and CdTe:Fe [4] solid solutions were investigated by the analyzing the shape of the edge luminescence band under laser excitation. The role of grain boundaries in the formation of properties of coarse-grained cadmium telluride was investigated by photoluminescence microprobe methods; it was shown that the impurity-defect compositions of the boundary and internal regions of single-crystal grains with sizes of 1 - 2 mm are significantly different [5] [6]. However, the influence of structural and point defects on the formation of the photoluminescence (PL) spectrum of fine-grained ($d_{cr} \leq 1 \mu\text{m}$) semiconductor samples has not been considered to date.

In this paper, we report the results of studying the mechanisms of formation of LTPL spectrum and their relationship with the anomalous photovoltaic (APV) properties of obliquely deposited CdTe and CdTe:In films in dependence of the degree of their structural imperfection. It was found previously [7] [8] that doping with In impurity and subsequent thermal treatment (TT) improve significantly the photovoltaic parameters of CdTe films: the short-circuit photocurrent I_{sc} increases by two orders of magnitude, and the maximum photo-emf value V_{APV} increases by an order of magnitude. Here, the intrinsic and edge PL spectra of these films are analyzed at $T = 4.2$ K. The LTPL spectra of fine-grained polycrystalline CdTe and CdTe:In films with APV properties, in contrast to the spectra of single crystals and coarse-grained polycrystals, were found to contain no contributions from excitons and donor-acceptor pairs (DAPs), which are due to the generation of photo-emf in the boundary regions of crystallites (that leads to stimulation of intrinsic ($e-h$) luminescence and build-up of longitudinal optical (LO-) phonon repetitions in undoped samples). The red edge of the $e-h$ band exhibits a significant blue shift ($\Delta E_r \approx 20$ meV), which is determined by the point and structural defects of crystalline grains. The half-width of this band correlates with the peak value of the anomalously large photovoltage generated in the film.

2. Technology: Experimental Results

The objects of study, pure and In-doped obliquely deposited polycrystalline films with a thickness of $\sim 1.0 \mu\text{m}$ and an area of $5 \times 20 \text{ mm}^2$, were obtained from CdTe powder by thermal evaporation in vacuum (residual gas pressure $(1 - 4) \times 10^{-2} \text{ Pa}$) onto a glass substrate at a temperature $T_s = 500 - 550 \text{ K}$ [7] [8]. The sizes of individual crystallites were $0.7 - 1.0 \mu\text{m}$. CdTe films at room temperature, illuminated by an incandescent lamp with intensity $L \approx 10^4 \text{ lx}$, generated photovoltage $V_{APV} \approx 600 \text{ V}$ and short-circuit current $I_{sc} \approx 10^{-10} \text{ A}$. As-prepared CdTe: In samples with a thickness $d = 0.5 - 0.8 \mu\text{m}$ turned out to have a lower resistivity and rather weakly pronounced APV properties ($V_{APV} = 50 - 100 \text{ V}$). However, after a TT at a temperature $450 - 550 \text{ K}$ for 3 - 5 min in air in the presence of coactivator CdCl_2 vapor, they generated a photovoltage up to $(2 - 4) \times 10^3 \text{ V}$, and the short-circuit photocurrent was as high as $I_{sc} \approx 10^{-8} \text{ A}$. The photovoltaic parameters of the films practically did not degrade during a year.

When measuring LTPL spectra, film samples were directly immersed in pumped liquid helium at a temperature of 4.2 K. Spectra were recorded on a system based on a DFS-24 spectrometer, operating in the photon-counting mode at a minimum slit width of 0.04 meV. Intrinsic excitation of semiconductor was performed by a 7-mW cw gas-discharge Ar^+ laser beam, focused on the CdTe layer surface into a spot $0.4 \times 0.4 \text{ mm}^2$ in size. The experiment was performed under conditions of normal illumination and close-to-normal emission.

The LTPL spectrum of undoped CdTe film in the vicinity of the fundamental absorption band is presented in **Figure 1(a)** in comparison with the PL spectrum of pure single-crystal sample from [6] (dotted line), which expands only to the frequency region $\hbar\omega < E_g$ and consists of an exciton line ($E_{ex} \approx 1.59 \text{ eV}$), DAP line ($E_{DAP} \approx 1.54 \text{ eV}$), and their LO-phonon repetitions. As can be seen, the CdTe polycrystalline film and CdTe single crystal have radically different LTPL spectra.

The main contributions to the film LTPL are from the radiative recombination of $e-h$ free carriers (A line with a half-width of $14.2 \pm 0.1 \text{ meV}$) and edge luminescence with a relatively wide doublet structure (B and C emission lines with half-widths of $18.5 \pm 0.1 \text{ meV}$ and $32.2 \pm 0.1 \text{ meV}$, respectively), whereas the exciton and DAP luminescence channels and their phonon repetitions are not observed against the background of the A , B , and C lines. The presence of sharp long-wavelength boundary $\hbar\omega = 1.627 \text{ eV}$ of the intrinsic emission band is indicative of perfect crystal structure of individual grains. Note that the red edge of the A line is blue-shifted by 0.021 eV in comparison with the bottom of the conduction band of CdTe single crystal (the vertical dash-dotted

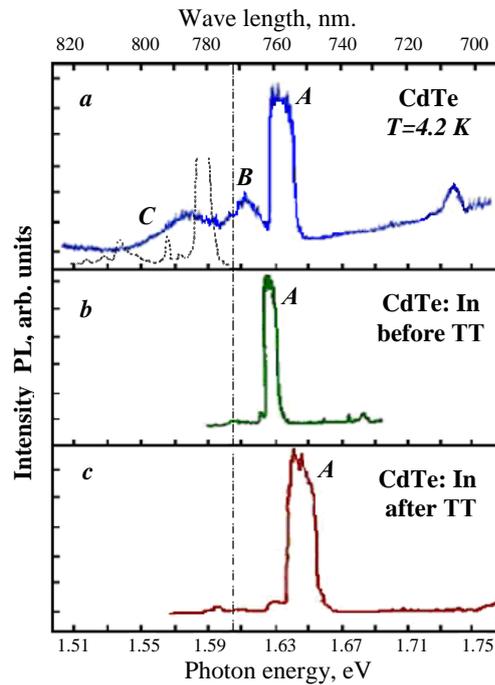


Figure 1. The experimental LTPL spectrum of undoped (a), which is alloyed by In doped CdTe films before (b) and after (c) of the TT. Dashing line is a PL spectrum of undoped monocrystalline CdTe [6], but the dotted line is shown upper border its forbidden band at 4.2 K.

line in **Figure 1(a)** at $T = 4.2$ K ($E_g = 1.606$ eV [9]). This feature can hardly be explained by, for example, the existence of internal mechanical tensile stress in a thin CdTe film because of the difference in the thermal expansion coefficients or interatomic distances in the film and substrate, which would lead to an increase in the band gap E_g .

It can be seen in **Figure 1(a)** that the peak energies of the A, B, and C emission lines differ from the energy of longitudinal optical phonon in CdTe: $\hbar\omega_{LO} = 0.021$ eV [9]. Hence, one can state that the symmetric B line is an LO-repetition, and the C line is a 2LO repetition of the intrinsic A emission band, which, as well as the fundamental band, were absent in the spectra of single crystal and large-crystallite polycrystal at a laser excitation intensity ~ 0.44 W/cm². The flat maximum of the C emission line is shifted from the A line by an energy somewhat exceeding $2\hbar\omega_{LO}$ and has a long-wavelength tail, which indicates that this spectral line is obviously formed as a result of e - h recombination with subsequent emission of $2LO + nLA$ phonons.

Figure 1(b) shows an LTPL spectrum of a CdTe:In film that was not subjected to TT. One can see that doping a film with indium impurity to a concentration not lower than $10^{17} - 10^{18}$ cm⁻³ distorts to a great extent its LTPL spectrum. First, the half-width of the A line ($\Delta_A \approx 6$ meV) is significantly reduced, which correlates with the decrease in V_{APV} by almost an order of magnitude for an as-prepared CdTe:In film in comparison with undoped CdTe film; second, the B and C lines disappear, as well as the hot PL channel; and, third, the red edge of the A line is red-shifted by 3–5 meV. Apparently, donor substitutional (In_{Cd}) or interstitial (In_i) impurities [9] [10] in fine-grained CdTe form an efficient nonradiative recombination channel, thus reducing strongly the role of LO and LA phonons.

The LTPL spectrum of the CdTe:In film subjected to TT under optimal conditions does not change radically (**Figure 1(c)**). However, it should be noted that TT leads to broadening of the A line by a factor of almost 3 ($\Delta_A \approx 17$ meV), in correspondence with the increase in V_{APV} to 3×10^3 V and blue shift of the A-line red edge by ~ 11 meV in comparison with the unannealed CdTe:In film.

3. Discussion

Let us analyze qualitatively the mechanism of formation of the A line in **Figure 1** and interpret its main parame-

ters in dependence of technological factors. We will consider the photoexcitation of a fine-grained semiconductor from the intrinsic absorption region with intensity L_0 . It is known [11] that, when considering the emission from polycrystalline samples, one should arbitrarily distinguish the contributions from the grain-boundary region (GBR), space-charge region (SCR), and quasi-neutral region (QNR):

$$L = \beta L_0 = L_{\text{GBR}} + L_{\text{SCR}} + L_{\text{QNR}}, \tag{1}$$

where β is the quantum yield. Obviously, in coarse-grained samples ($d \gg \ell_{Di}$, where d is the linear crystallite size and ℓ_{Di} is the Debye screening length), the QNR plays a key role, and the problem under consideration is reduced to the well-known case of bulk photoluminescence. However, in fine-grained ($d \approx \ell_{Di}$) polycrystalline films, the GBR and SCR contributions may be dominant, while QNR does not affect much the formation of LTPL.

As can be seen in **Figure 1(a)**, intrinsic emission (dotted line in [6]) is not observed in pure CdTe single crystals excited by a laser beam of specified intensity ($\sim 0.44 \text{ W/cm}^2$). The reason is that the ($e-h$)-radiative lifetime τ_r of photocarriers exceeds greatly their lifetimes τ_0 determined by the formation of excitons or phonon emission. The total lifetime of a nonequilibrium electron is given by the expression

$$\frac{1}{\tau} = \frac{1}{\tau_r} + \frac{1}{\tau_0}, \quad \frac{1}{\tau_0} = \frac{1}{\tau_{LO}} + \frac{1}{\tau_{LA}} + \frac{1}{\tau_{ex}} + \frac{1}{\tau_{DA}} + \frac{1}{\tau_M} + \dots, \tag{2}$$

where $\tau_{LO}, \tau_{LA}, \tau_{ex}, \tau_{DA}$ are the lifetimes of electron in a given energy state, related to the formation of LO phonons, LA phonons, excitons, and DAPs, respectively, and τ_M is the Maxwell relaxation time. The A-line half-width $\Delta_A \approx 14 \text{ meV}$ corresponds to $\tau_r \approx 3 \times 10^{-11} \text{ s}$. Therefore, the observed LTPL spectrum of CdTe film with APV properties obviously corresponds to the reverse situation: $\tau_r \leq \tau_0 \approx \tau_{ex}$, as is evidenced by the absence of exciton- and DAP-emission channels in the spectrum. On the other hand, the Maxwell relaxation time $\tau_M = \varepsilon \varepsilon_0 / \sigma$ in high-resistivity samples (objects of our study) is rather long; therefore, the lifetimes of photocarriers in the corresponding bands are mainly determined, according to (2), by the interband radiative recombination ($\tau \approx \tau_r \leq \tau_0, \tau_M$). This is, apparently, the main cause of the intrinsic PL build-up and suppression of exciton emission in fine-grained polycrystalline direct-gap semiconductors of the CdTe type. In the case of weak surface recombination, the SCR contribution to PL may be dominant.

It should be noted that surface PL and photo-emf always coexist in fine-grained polycrystals under certain conditions. Let us consider a structural model (**Figure 2**) of an obliquely deposited fine-grained ($d \sim \ell_{Di}$) polycrystalline film. Within this model, crystallites, their boundaries, and pores between them in the electric current transmission direction are considered to form a linear periodic chain of semiconductor-insulator-semiconductor (SIS) layers with symmetric surface potential barriers, connected in series. Under illumination, each elementary SIS cell, due to the absorption of light in asymmetric SCRs and spatial separation of photocarriers, ge-

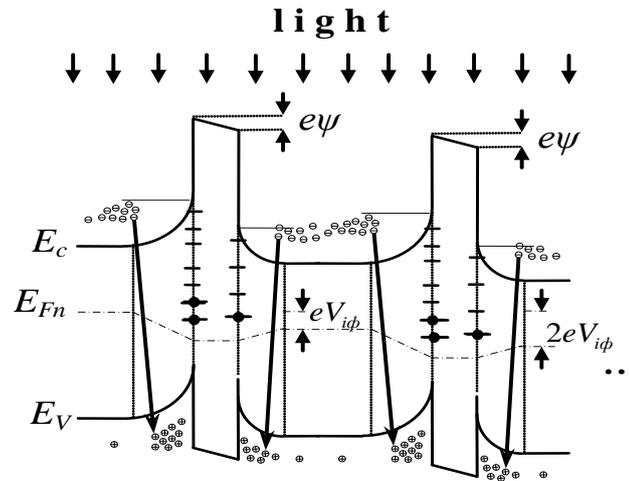


Figure 2. The band of diagram energy of the linear chain semiconductor crystalline grains with asymmetric potential barriers among intercrystalline interface (IL), at illumination by light, bring to APV and PL generation.

nerates not only PL but also a low surface photo-emf $V_{iP} = \psi_0 - \psi$, where $\psi_0 = (\varphi_{01} - \varphi_{02})/e$, $\psi = (\varphi_1 - \varphi_2)/e$ are the contact potential differences between neighboring grains in darkness and under illumination, respectively; e is the elementary charge; and $\varphi_{01}, \varphi_{02}$ and φ_1, φ_2 are, respectively, the heights of surface potential barriers on the left and right sides of the insulating layer (IL) before and after illumination. Then, it is natural that a linear SIS chain generates high-voltage photo-emf $V_{APV} = N \cdot V_{iP}$ (N is the number of SIS cells). If the potential barriers at grain boundaries are symmetric, or the film is sufficiently thick, or the film photoconductivity is high, the APV effect is absent because of shunting SIS with resistances R_{sh} or r_{sh1}, r_{sh2} (Figure 3), although surface PL may occur in this case.

Strictly speaking, the PL of a polycrystalline film is formed at different depths and microregions, based on different mechanisms of radiative recombination. Thus, it is rather difficult to perform exact analytical calculation of the PL spectrum. However, some rough approximations can be made based on formula (1) and the above physical considerations. In particular, preliminary quantitative analysis of the spectra of A emission line shows that it can be described in the first approximation by the formula

$$L(\omega) = A \sqrt{\hbar\omega - (E_g + \Delta E_r)} \cdot \exp\left(-\frac{\hbar\omega - (E_g + \Delta E_r)}{kT_{eh}}\right), \quad (3)$$

where A is a constant determined by the film type and the excitation conditions; E_g is the band gap of CdTe single crystal; k is the Boltzmann constant; T_{eh} is the average characteristic temperature of photocarriers, which differs significantly from lattice temperature T ; and $\Delta E_r = \hbar\omega_r - E_g$ is the difference between the red edge of the A line and E_g . Naturally, the second and third factors in the right-hand side of (3) are due to the densities of states in simple bands and quasi-equilibrium photocarrier distribution functions.

The theoretical (according to (3)) and experimental spectra of the fundamental LTPL band of fine-grained CdTe and CdTe:In films with APV properties are compared in Figure 4. The values of the parameters $\Delta E_r \approx kT_{eh}$ are chosen based on the blue shift of the red edge of the A line from the experimental spectra in Figures 1(a)-(c): $\Delta E_r = 21$ meV (curve 1 for a pure CdTe film), 17 meV (curve 2, CdTe:In without TT), and 29 meV (curve 3, CdTe:In after TT). One can see that the calculated spectral lines 1 - 3 are in good agreement with the experimental results. However, the short-wavelength edges of the spectra differ significantly. The experimental data demonstrate stronger thermalization of hot photocarriers with a characteristic temperature $T_{eh} < \Delta E_r/k$, which suggests the existence of additional scattering channels for high-energy nonequilibrium free carriers.

A simple calculation shows that the spectral half-width of the A line, Δ_A , is directly proportional to the photocarrier temperature, which determines the blue shift of its red edge, ΔE_r . This is in qualitative agreement with the changes in the spectral characteristics of the A line in Figures 1(a)-(c). Doping a CdTe film with In impurity leads to a decrease in φ_{0i} and kT_{eh} ; thus, one can see in Figure 1(b) that ΔE_r decreases by 3 - 5 meV and Δ_A decreases by a factor of almost 3 (to 6 meV). According to the data of Figure 3, resistances R_{sh} , r_{sh1} , and R_D also decrease, and the film passes to a state with lower resistivity, as a result of which short-circuit photocurrent I_{sh} increases and the maximum value of photo-emf V_{APV} decreases. Subsequent optimal TT, due to the self-compensation processes [12], transforms the film to the high-resistivity state (not only due to the rise in microresistances

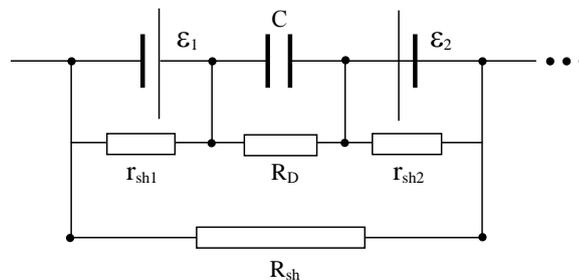


Figure 3. The equivalent electrical circuit of one structured cell SIS under the action of light, generating photo-emf. $\varepsilon_1, \varepsilon_2$ - surface photo-emf, generated by APV on the left and on the right from the interface; r_{sh1}, r_{sh2} - shunting their resistance in favor of the surface conductivity, R_{sh} - shunting resistance of the channel conductivity; C and R_D - electro-capacitance and active resistance of the interface.

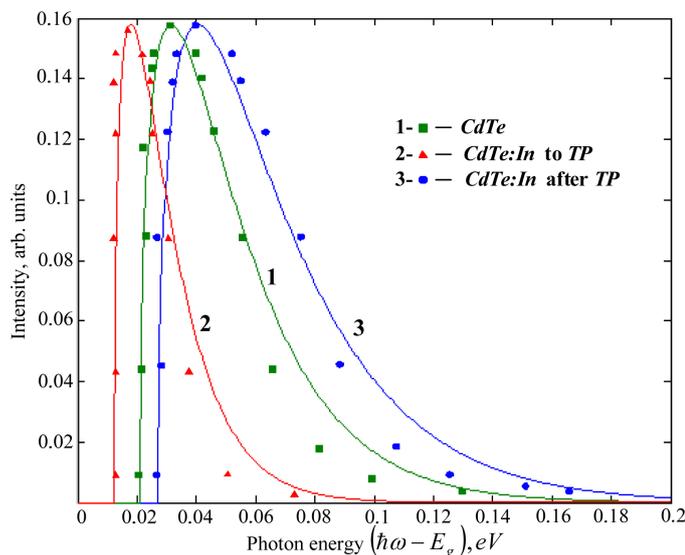


Figure 4. The comparison of theoretical (the utter curves) and experimental (points) spectrums of LTPL fundamental band of fine grained CdTe APV films at $T = 4.2$ K .

but also as a result of the increase in φ_{0r} and the SCR expansion). **Figure 1(c)** shows that Δ_A increases to 17 meV, while ΔE_r rises to 29 meV.

4. Conclusions

1) The LTPL spectra of fine-grained CdTe films excited by a cw gas-discharge Ar^+ laser contains a fundamental emission band with a half-width $\Delta_A \approx 10 - 20$ meV (A line) and its LO- and 2LO-phonon repetitions.

2) A blue shift of the red edge of the A line was revealed, which was related to the e-h recombination of hot photocarriers, separated by the electric field of the boundary SCRs in crystallites. Shift ΔE_r correlates with the spectral half-width Δ_A , which depends on the structural defects of the film.

3) A correlation was found between the LTPL spectrum and the APV properties of CdTe and CdTe:In films. The intrinsic luminescence band is due to the presence of potential barriers at grain boundaries, which generate surface photo-emfs; the asymmetry of the latter results in APV properties. Doping with In donor impurity suppresses the role of LO and LA phonons in the processes of relaxation of hot photocarriers in energy and, thus, leads to quenching of the doublet band. Further TT of an obliquely deposited film stimulates the asymmetry of potential barriers at grain boundaries, which manifests itself in the inhomogeneous broadening and sharp activation of the intrinsic band, the half-width of which (Δ_A) and the shift of the edge of which (ΔE_r) is related to the maximum value of photovoltage V_{APV} .

The method of joint analysis of the LTPL spectra and photoelectric properties of fine-grained CdTe polycrystals, proposed in this study, can successfully be used to investigate properties of other semiconductor film structures.

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